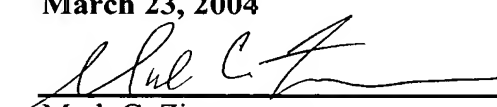




PATENT
Docket No. 20063/OG03-051

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant: Seung Jong YOO)	I hereby certify that this paper is
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Group Art Unit: Unknown)	March 23, 2004
)	
Examiner: Not yet Assigned)	Mark C. Zimmerman
)	Registration No. 44,006
)	Attorney for Applicant(s)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The patents and/or publications listed on the enclosed PTO Form-1449 are submitted pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the patents or publications are enclosed.

TIME OF FILING

This information disclosure statement is being filed with the application or within three months of the filing date of the application or date of entry into the national stage of an international application or, to the best of the undersigned's knowledge, before the mailing date of a first Office action on the merits, whichever event occurs last. In accordance with 37 CFR §1.97(b), no certification or fee is required.

METHOD OF PAYMENT

☒ No fee is required.

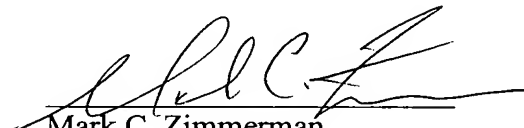
The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 50-2455. A copy of this paper is enclosed.

Correspondence Address:

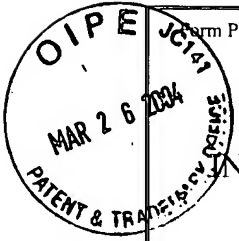
Respectfully submitted,

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By:


Mark C. Zimmerman
Registration No.: 44,006

March 23, 2004



Form PTO-1449 (Modified)

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket No.
20063/OG03-051Serial No.
10/747,603Applicant
Seung Jong YOOFiling Date
**December 29,
2003**Group Art Unit
Unknown

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*EXAMINER INITIALS		DOCUMENT NUMBER	ISSUE DATE	INVENTOR(S)	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A01	6,376,353	04-23-02	Zhou et al.	438	612	07-03-00
	A02	6,560,862	05-13-03	Chen et al.	29	843	02-06-01

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.